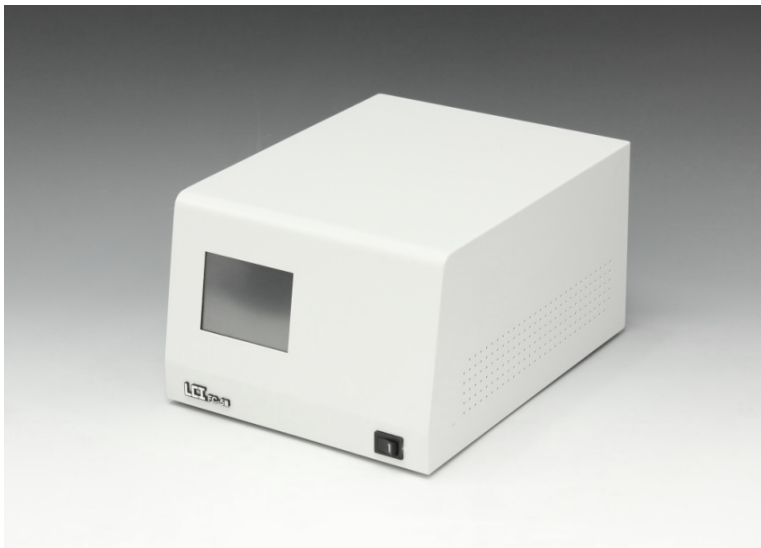


# FC-5N

## Automatic CO<sub>2</sub>/ Air Mixer



- Automatic CO<sub>2</sub> gas mixing and supply system (Maximum flow rate is 200 ml/min)
- PID control system for precise control of the CO<sub>2</sub> concentration
- Produces CO<sub>2</sub>/ air mixed gas from 100% CO<sub>2</sub> gas cylinder and ambient air
- Solenoid valve and a reservoir for gas ripening
- Internal air pump to provide a large flow
- Able to regulate the concentration, to program the concentration gradients and to record CO<sub>2</sub> concentration over time with CCP ver.7 software or MetaMorph software
- 3 kinds of the automatic CO<sub>2</sub>/ air gas mixer depending on the flow rate



2.5 L/min CO<sub>2</sub>/ air mixer



30 L/min CO<sub>2</sub>/ air mixer

### Specifications

Sensor	NDIR CO <sub>2</sub> sensor
Control range	1 – 20 % CO <sub>2</sub>
Flow rate	Max. 200ml/min, 2.5 L/min, 30 L/min
CO <sub>2</sub> control method	PID, solenoid valve

### FC-5N Gas Pressure Setting

### Gas Pressure for Regulator

CO<sub>2</sub>

- 0.5 kg/cm<sup>2</sup> (50 cc/min)
- 0.8 kg/cm<sup>2</sup> (100 cc/min)
- 1.1 kg/cm<sup>2</sup> (150 cc/min)
- 1.4 kg/cm<sup>2</sup> (200 cc/min)

#### Model No.

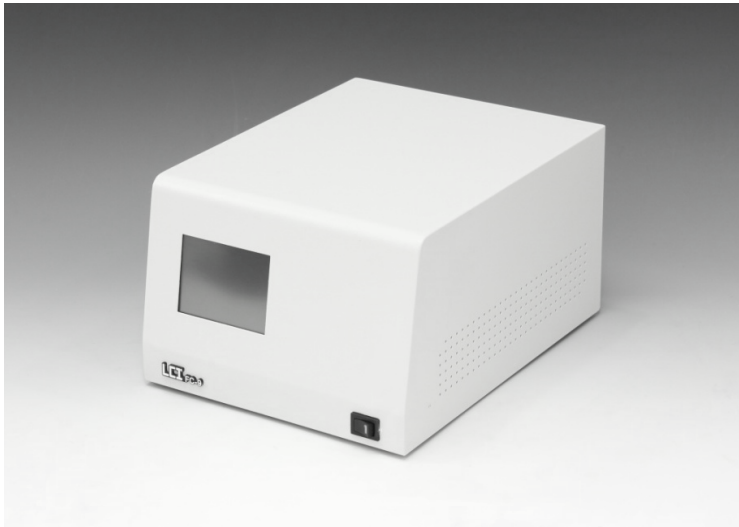
FC-N-10  
FC-HF-30  
FC-HF-300

#### Product

FC-5N (meter (Automatic CO<sub>2</sub>/Air mixer), Max 200 ml/min)  
High flow rate automatic CO<sub>2</sub>/Air mixer, Max 2.5 L/min  
Very high flow rate automatic CO<sub>2</sub>/Air mixer, Max 30 L/min

# FC-9N

## Automatic O<sub>2</sub>/ CO<sub>2</sub>/ N<sub>2</sub> Mixer



- Automatic O<sub>2</sub> / CO<sub>2</sub> / N<sub>2</sub> gas mixing and supply system.
- PID control system for the precise control of the O<sub>2</sub> and CO<sub>2</sub> concentrations.
- Produces mixed gas from 100% CO<sub>2</sub>, 100% O<sub>2</sub> and 100% N<sub>2</sub> gas cylinders
- Produces very low to high concentrations of O<sub>2</sub> mixed gas
- Internal air pump to make CO<sub>2</sub> /air mixed gas

- Usable 100% O<sub>2</sub> cylinder to control full range of the O<sub>2</sub> levels from 0% to 100% O<sub>2</sub>
- Dynamic orifice control valve
- Digital flow meter
- A reservoir for gas ripening
- Able to regulate the concentration, to program concentration gradients and to record the gas concentrations over time with CCP ver.7 software or MetaMorph software
- FC-9 are customizable and able to adjust the high-flow rate of the mixed gas.

### Specifications

Sensor	O <sub>2</sub>	Thermal conductive flow sensor
	N <sub>2</sub>	Thermal conductive flow sensor
	CO <sub>2</sub>	NDIR CO <sub>2</sub> sensor
Control range	O <sub>2</sub>	1 ~20 %
	CO <sub>2</sub>	1 ~ 20 %
Control method	Flow rate	Max. 200 ml/min
	O <sub>2</sub>	PID, dynamic orifice control valve
	CO <sub>2</sub>	PID, solenoid valve
	N <sub>2</sub>	PID, dynamic orifice control valve

### Gas Pressure Setting

N<sub>2</sub>  
O<sub>2</sub>  
CO<sub>2</sub>

### Gas Pressure for Regulator

1.5 kg/cm<sup>2</sup>  
1.5 kg/cm<sup>2</sup>  
0.3 kg/cm<sup>2</sup> (50 cc/min)  
0.6 kg/cm<sup>2</sup> (100 cc/min)  
0.9 kg/cm<sup>2</sup> (150 cc/min)  
1.2 kg/cm<sup>2</sup> (200 cc/min)

#### Model No.

FC-R-50

#### Product

FC-9N (Automatic O<sub>2</sub>/CO<sub>2</sub>/N<sub>2</sub> mixer)